



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79976

OSHIMA, Yuichi

Appln. No.: 10/779,740

Group Art Unit: 2818

Confirmation No.: 2078

Examiner: NGO, Ngan V.

Filed: February 18, 2004

For: NITRIDE SEMICONDUCTOR SUBSTRATE AND ITS PRODUCTION METHOD

AMENDMENT UNDER 37 C.F.R. § 1.114(c)

MAIL STOP RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Prior to first Action in this Request for Continued Examination, please amend the above application as follows.

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